No	ITEM	SPEC	RESULT
1	Total Focus Deviation	Max-Min ≤ 0.20μm	0.470μm
2	Lens Astigmatism	|V-H| ≤ 0.30μm	0.224μm
3	Lens Dynamic Distortion	X,Y = Within ±50nm	X = -2nm ~ 44nm Y = -20nm ~ -36nm
4	Wafer Flatness Accuracy	1) Flat Within ≥ Max-Min 3.0μm 2) L.F.S Within ≥ Max-Min 0.8μm	1. 1.443μm 2. 0.45μm
5	Exposure Power	Within ≥ 650mW/cm2	603mW/cm2
6	Illumination Uniformity	Within ±1.5%	0.839%
7	Stage Precision Accuracy 1) Stepping Accuracy 2) Backlash Accuracy	1) 3σ ≤ 50nm 2) 3σ ≤ 50nm	1) X: 12nm Y: 16nm 2) X: 15nm Y: 13nm
8	Wafer Pre-Alignment Repeatability	3σ≦15μm	X : 4.113 μm Y : 5.488 μm T : 5.764 μm
9	Integrator Accuracy	Target: Ave ≤ 1%	Ave Max = 0.01%
10	Alignment Accuracy 1) FIA-EGA 2) LSA-EGA	FIA-EGA = |M| + 3σ ≤ 75nm LSA-EGA = |M| + 3σ ≤ 75nm	1) X = ±12nm Y = ±75nm 2) X= ±61nm Y = ±14nm